

RESIDUAL GAS ANALYSIS IN A UHV- APPLICATION GENERATED BY TURBO PUMP IN COMBINATION WITH DRY BACKING PUMP

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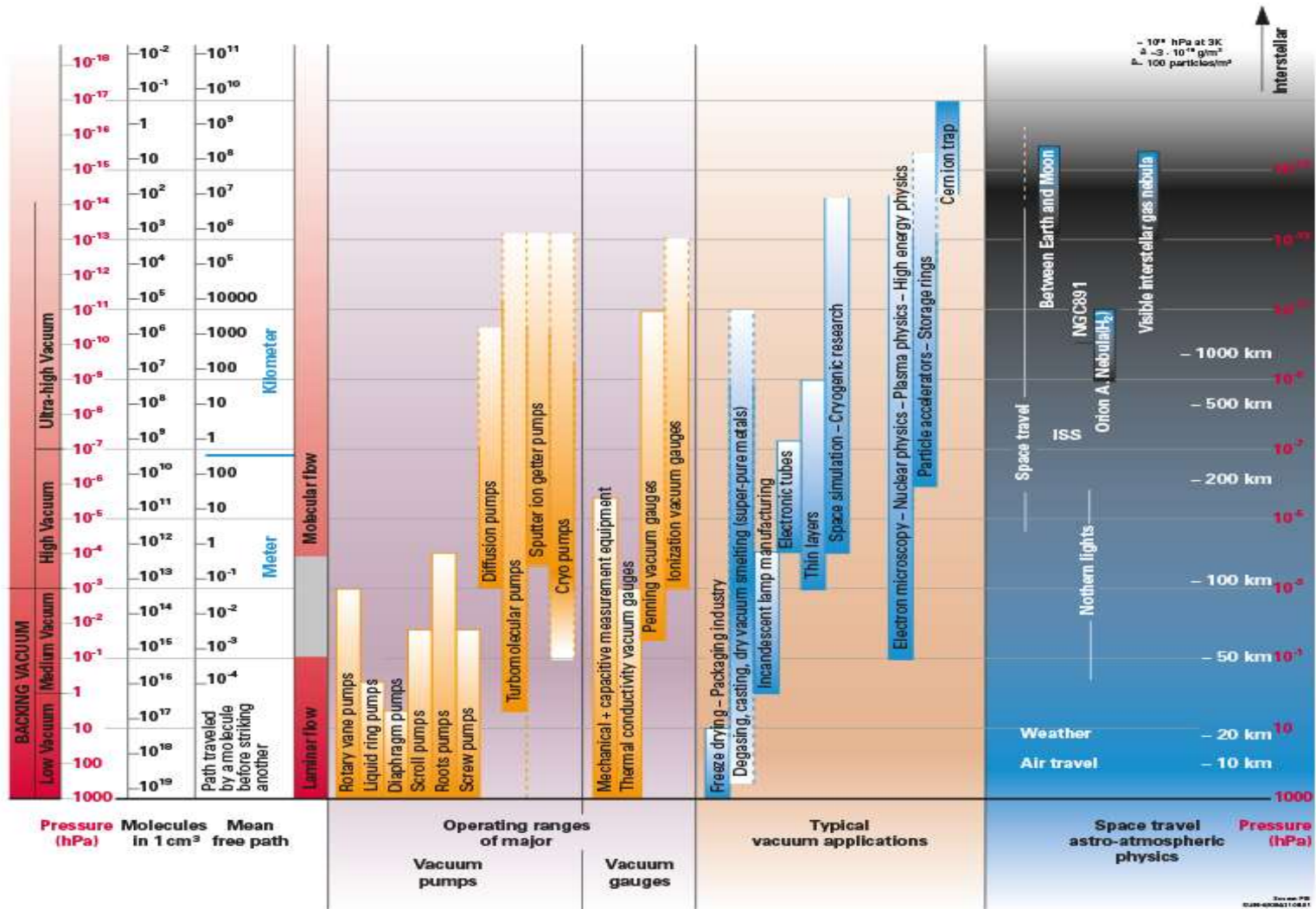
Content

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- Summary

Requirements

- No Hydrocarbons
- Low maintenance
- Smaller number of pumps
- High compression ratio for Hydrogen

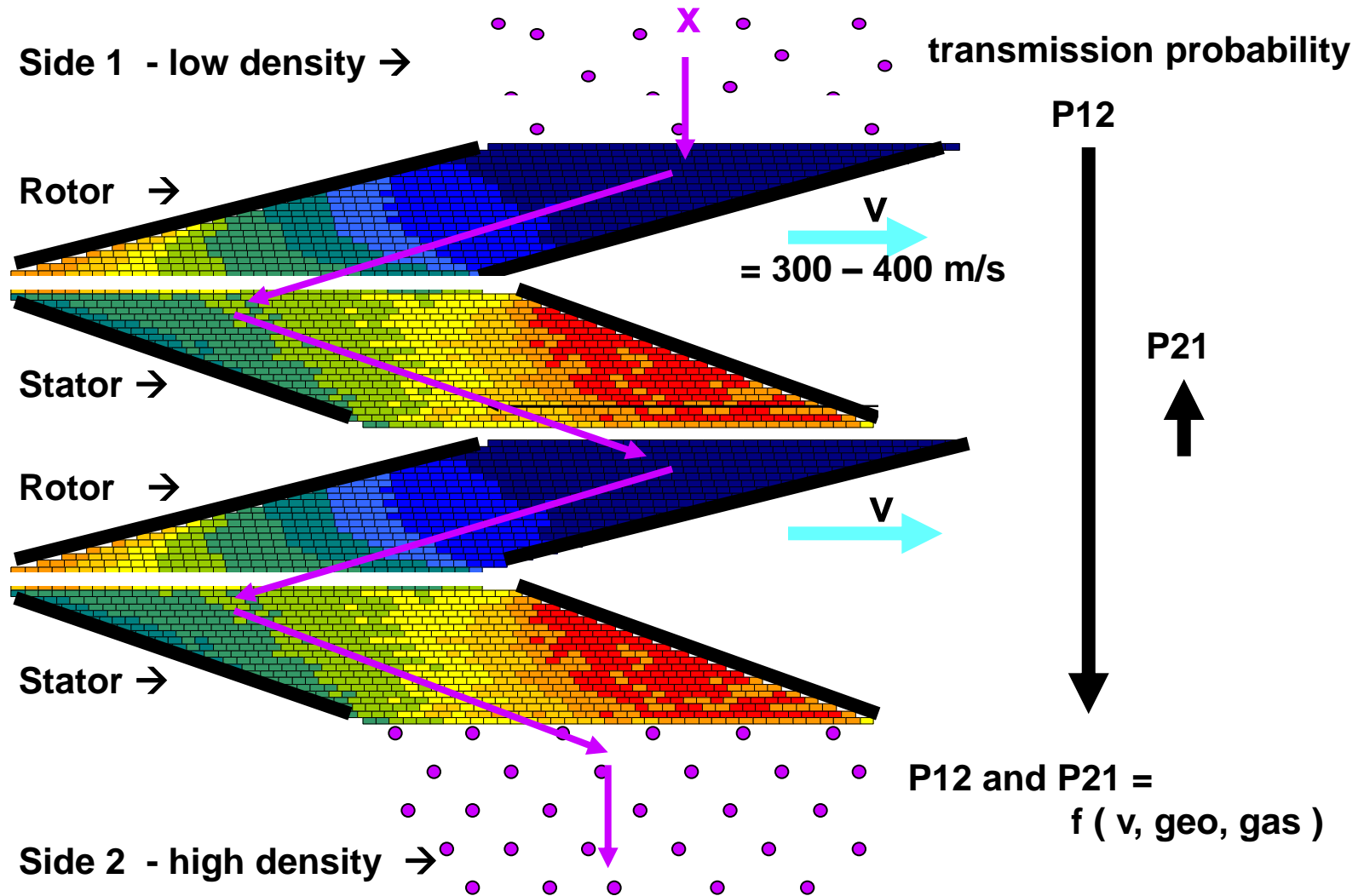
Vacuum Regimes



Vacuum Chamber for UHV

- Stainless Steel
 - Designed for UHV e.g.
 - No virtual leaks
 - low flow restriction
- Metallically sealed
- Surface treatment
 - Electro polished
 - Cleaned
- Leak checked
- Bakeable $T > 120 \text{ }^{\circ} \text{C}$

Theory of turbo-pumping effect

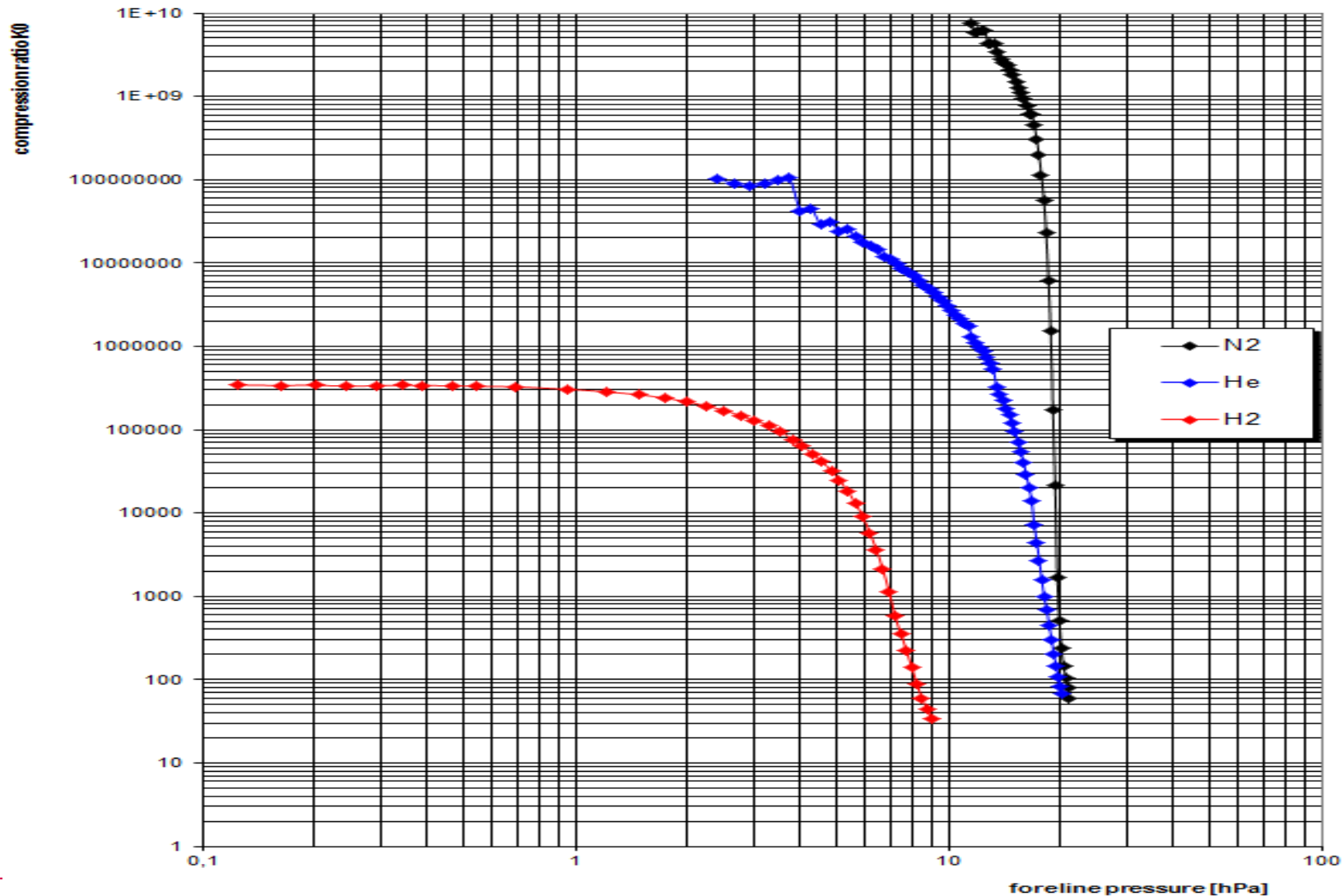


Technical Parameters of Turbo Pump

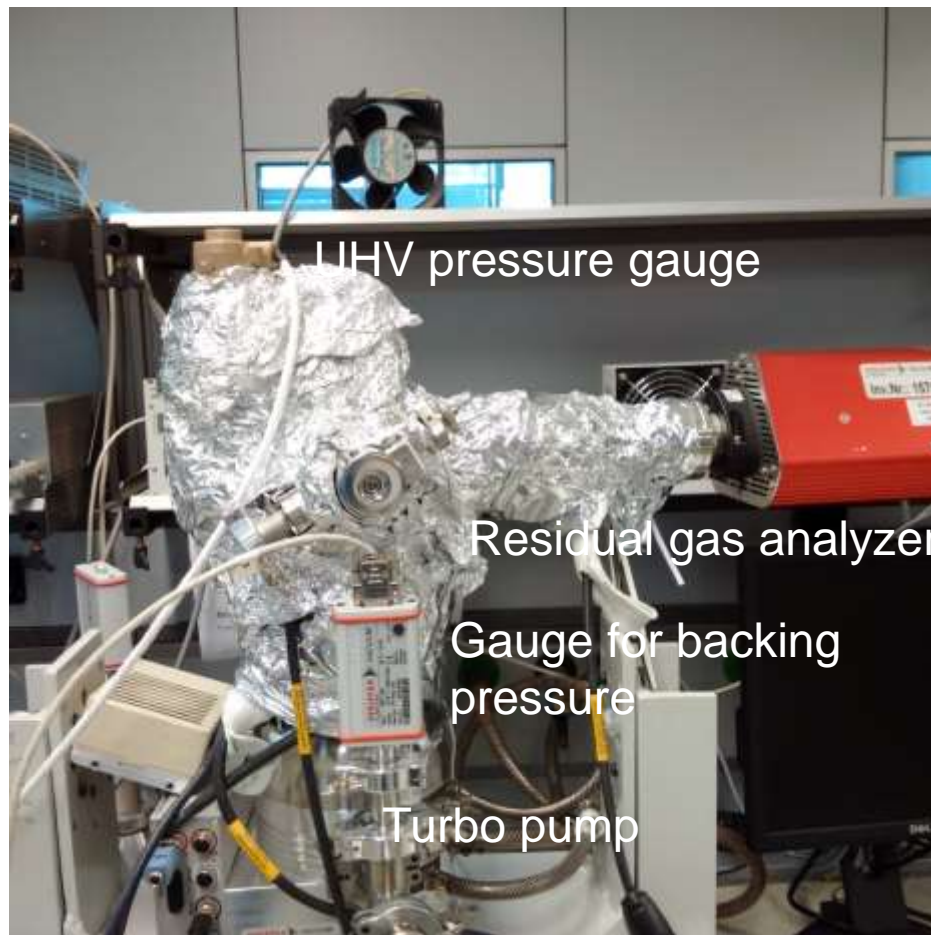


Bearing	Magnetically Levitated
Compression ratio for Ar	$> 1 \cdot 10^{11}$
Compression ratio for H ₂	$5 \cdot 10^5$
Compression ratio for He	$> 1 \cdot 10^8$
Compression ratio for N ₂	$> 1 \cdot 10^{11}$
Cooling method, standard	Water
Flange (in)	DN 100 CF-F
Flange (out)	DN 16 ISO-KF
Fore-vacuum max. for N ₂	20 hPa
Pumping speed for Ar	250 l/s
Pumping speed for H ₂	170 l/s
Pumping speed for He	215 l/s
Pumping speed for N ₂	255 l/s

Gas Type Dependent Compression Ratio



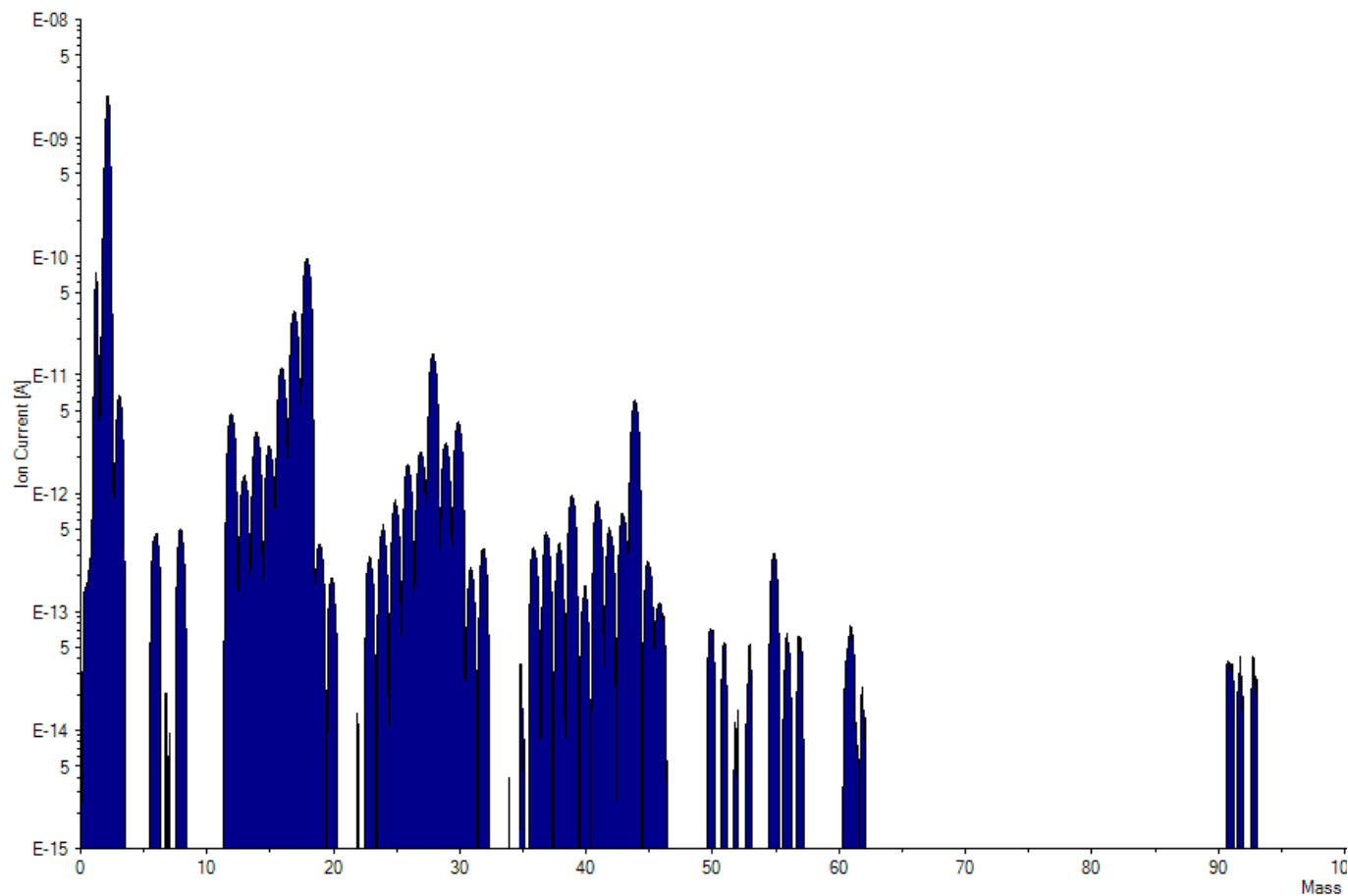
Experimental Set Up



Devices used in Experiment

- Turbo Pump: HiPace 300 M
- Backing Pump: Multi stage roots pump ACP 28
- Total Pressure gauge: Bayard-Alpert Hot Cathode Gauge
- Residual Gas Analyzer: Quadrupole Mass Spectrometer PrismaPlus QMG 220
- Volume of Chamber: $V = 9 \text{ l}$
- Baking: 48 h at $T = 140 \text{ }^\circ\text{C}$

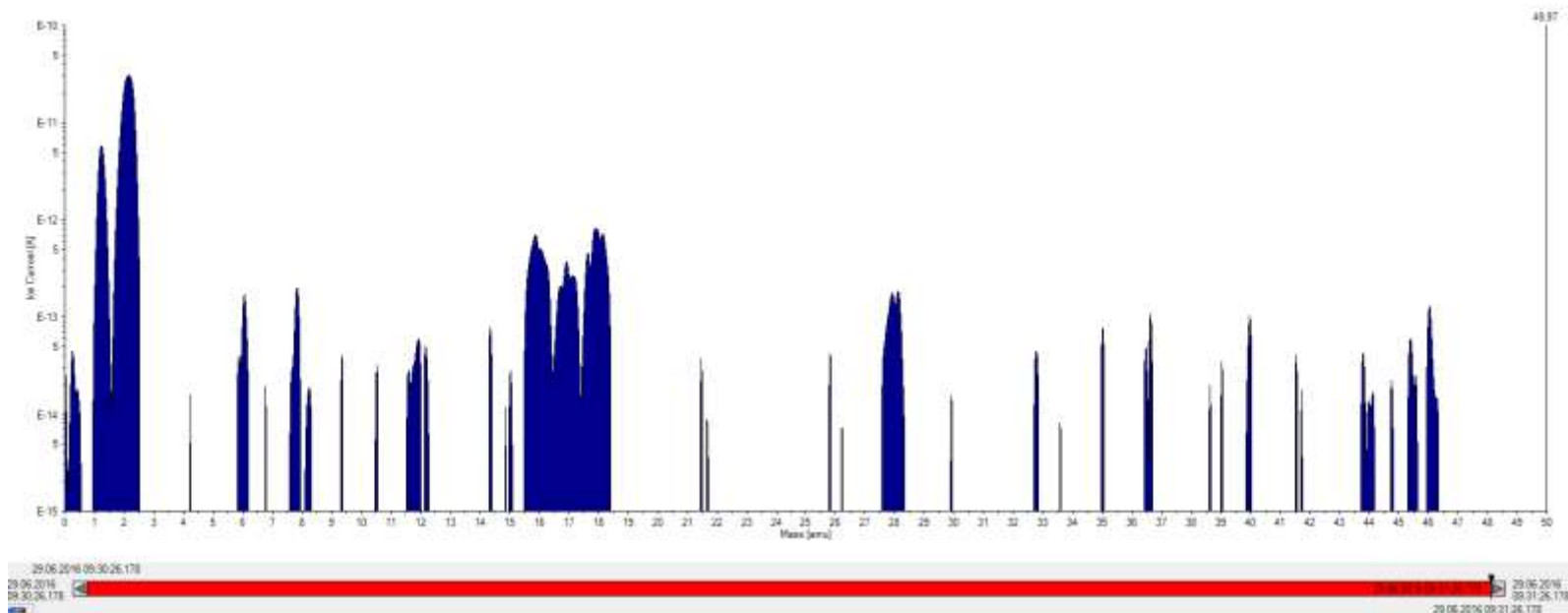
Residual Gas Analysis before Baking



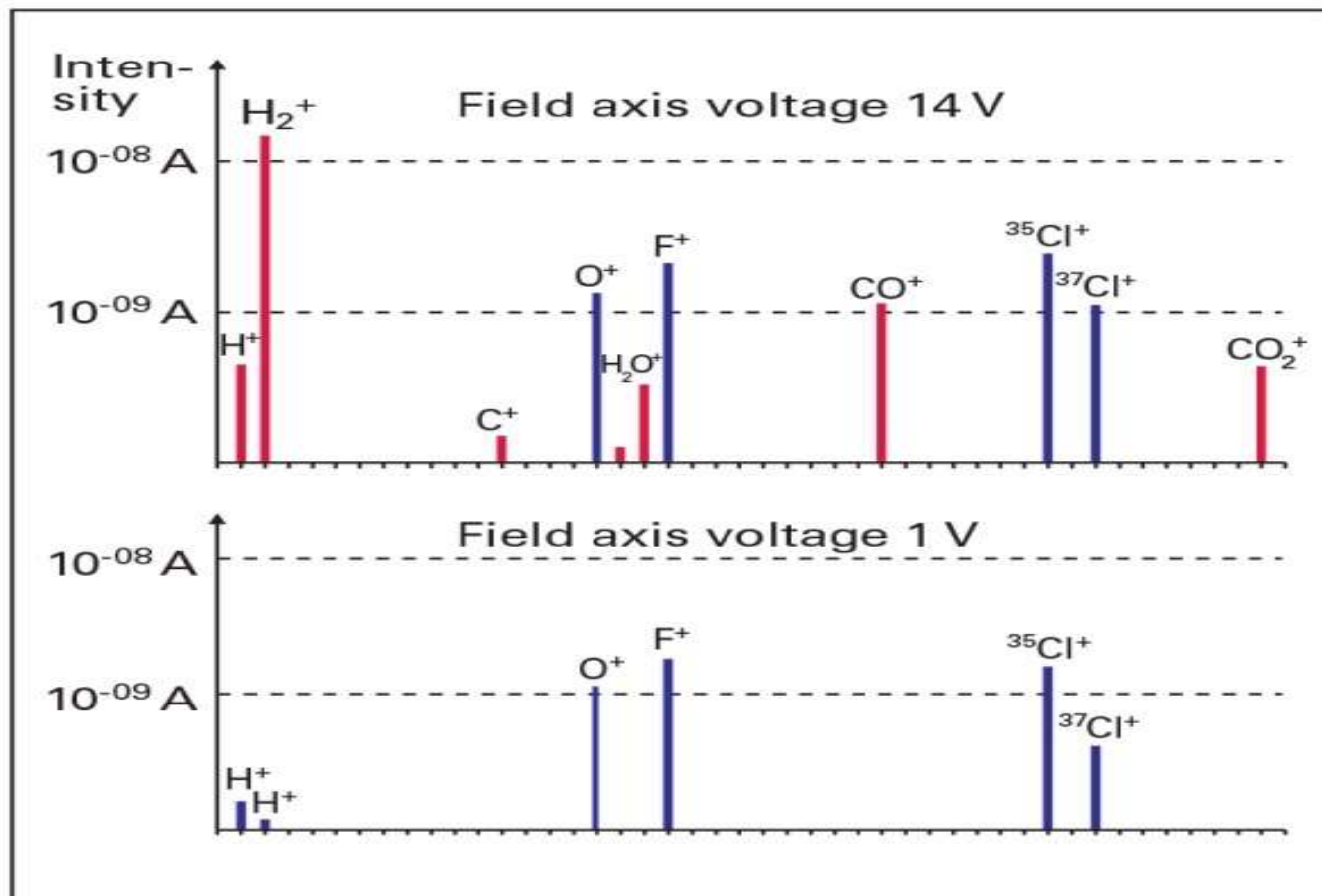
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Residual Gas Analysis after Baking



Influence of ESD Ions



Summary

- Reduction of Hydrogen concentration by 2 orders of magnitude
 - High compression ratio for Hydrogen
- No Hydrocarbons:
 - Dry backing pump
 - Magnetically levitated Turbo pump with high compression ratio
- Influence of ESD ions